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IFW
Serial No. 10/071,099

SEC.936

Amendment dated 21 June 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Jai Young WOO et al.

Group Art Unit: 2872

Serial No.: 10/071,099

Examiner: Thong Q. NGUYEN

Filed: 11 February 2002

**MICROSCOPE FOR INSPECTING
SEMICONDUCTOR WAFER**

AMENDMENT UNDER 37 C.F.R. § 1.116

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop AF
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

In response to the Office Action dated 29 March 2004, the period for response to which extends through 29 June 2004, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.